

## **Announcement for the faculty position of Assistant Professorship**

**1. Position title:** Assistant Professor of Laboratory for Materials and Structures, Institute of Innovative Research

**2. Research field:** Novel functional oxide thin films

Experimental research on thin film fabrication, structural and physical property investigations of new functional oxide materials.

**3. Minimum qualification:** Applicants must have a Ph.D. or Doctoral degree and ability to supervise graduate students and to give English classes on solid-state physics/chemistry, physical chemistry etc.

**4. Expected start date:** March 1st, 2018 or later.

**5. Term of office:** Appointment will be for up to 5 years. Reappointment may be possible. Employment is limited to a maximum of 10 years from the original date of employment.

Salary: Annual salary will be paid according to the National University Corporation Tokyo Institute of Technology Regulations on Wage and Salary for Staff on the Annual Salary System.

**6. Affiliation:** Laboratory for Materials and Structures, Institute of Innovative Research (Suzukake-dai Campus).

### **7. Documents to be submitted:**

- 1) Curriculum vitae (with photograph, telephone number, e-mail and mailing addresses) including academic background, professional carrier after high school, applicant's ResearcherID, and library-name of Google Scholar's profile.
- 2) Summary of major research achievements to date (A4 paper; 2 pages or less).
- 3) List of research achievements categorized into the following types:
  - a) refereed original articles, b) reviews and commentaries, c) books, d) patents.All authors in the same order as each publication should be clarified.
- 4) Reprints or copies of representative papers (no more than three articles).
- 5) Explanation of the academic significance and importance of the above representative papers (A4 or letter size, up to two pages totally).
- 6) List of awards received, invited or keynote lectures of international meetings.

- 7) List of acquired research and educational funds (fund name, project title, budget, and period of research or education project). Specify whether the applicant is the principal investigator or a co-investigator and the total and allotted budgets in the case of a co-investigator for each fund. Social activity records including activities in academic societies, and the list of awards.
- 8) Research and educational policy after taking this position (A4 paper; 2 pages or less)
- 9) Name and contact information (affiliation, address, and e-mail address) for a person who can evaluate your work.

**8. Deadline:** November 2nd, 2017

**9. Mailing Address for applications:**

Prof. Masaki Azuma, Office of Laboratory for Materials and Structures, Tokyo Institute of Technology, R3-28, 4259 Nagatsuta-cho, Midori-ku, Yokohama 226-8503, JAPAN

Applicants should send the application documents to the above address by a registered mail, with "Application for Assistant Professor" written in red on the envelope. Note that the documents and USB memory will not be returned. Submitted documents are strictly protected under the Privacy Policy of Tokyo Institute of Technology and will be used only for the purpose of applicant screening. Personal information will not be disclosed, transferred or loaned to a third party under any circumstances without legitimate reasons.

**10. Inquiries:** Prof. Masaki Azuma,  
e-mail: mazuma@msl.titech.ac.jp

Notes:

- 1) All application documents must be submitted as PDF files on USB memory together with the printouts of the curriculum vitae and the list of publications. We do not accept the application by e-mail or internet file attachment.
- 2) Tokyo Institute of Technology provides start-up funding through an internal supporting system, and successful applicant may have access to such system.
- 3) Tokyo Institute of Technology, in order to ensure a diverse workforce, guarantees equal opportunities for all individuals regardless of nationality or gender.
- 4) The personal information you provide will be used solely for this recruitment

and not for any other purpose.